

ATMI-521
Customer ID No.: 25559**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of:)

Applicants: Ying Ma, et al.)

Serial No.: 09/929,564)

Date Filed: August 14, 2001)

Title: Improved Chemical Mechanical Polishing
Compositions for Metal and Associated
Materials and Method of Using Same)

Group Art Unit: 3723

Examiner: Eileen P. Morgan

GROUP 3700

JUL 30 2003

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It hereby is certified by the person identified below that this paper is being facsimile transmitted by such person to the Commissioner of Patents and Trademarks on the date specified, to the Assistant Commissioner for Patents, Washington, DC 20231, and Transmitted by Facsimile under the provisions of 37 CFR 1.6(d).


Maggie ChappuisJuly 30, 2003
Date of Transmission703 872-9302
Facsimile Number**RESPONSE TO JUNE 18, 2003 OFFICE ACTION IN
U.S. PATENT APPLICATION 09/929,564 AND
PETITION FOR ONE MONTH EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 18, 2003 in the above-identified application, wherein a restriction requirement was imposed against the following claim groups: